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**CONFIRMATION NO. 2896** 

Bib Data Sheet							
SERIAL NUMBER 09/767,659	FILING DATE 01/22/2001 RULE	C	CLASS 414	GROUP ART 3652	UNIT	D	ATTORNEY OCKET NO. 736-1/AJT/MSS
APPLICANTS							
Richard N. Sav	rage, Scotts Valley, CA;						
Helder R. Carva Dan L. Cossent	gh, Santa Cruz, CA; alheria, Scotts Valley, C tine, Santa Cruz, CA; in, Santa Cruz, CA; r, Soquel, CA;	:A;Philip	A. Troiani, San	nta Cruz, CA;			
** CONTINUING DATA **********************************							
	ATIONS ************************************		:n				
** 04/23/2001	IGN FILING LICENSE	GRANIE	<u> </u>	•			¥
Foreign Priority claimed 35 USC 119 (a-d) conditions	yes no no Met after	ter	STATE OR	SHEETS	тот	AL	INDEPENDENT
met Verified and Acknowledged Ex	Allowance	Initials	COUNTRY CA	DRAWING 16	CLAI 6		CLAIMS 2
ADDRESS Maria S. Swiatek FLEHR HOHBACH T Four Embarcadero Ce San Francisco , CA 94111-4187	EST ALBRITTON & HE enter, Suite 3400	RBERT I	LLP				
TITLE Semiconductor wafer transfer system	processing system with	ı verticall	y-stacked proc	ess chambers	and sin	gle-ax	is dual-wafer
	☐ All Fees						



## United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

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SERIAL NUMBER 09/767,659	FILING DATE 01/22/2001 RULE	CLASS 414	GROUP AR 3652	, [	ATTORNEY DOCKET NO. 37736-1/AJT/MSS		
APPLICANTS							
Richard N. Sav	age, Scotts Valley, CA;				•		
Helder R. Carva Dan L. Cossent	gh, Santa Cruz, CA; alheria, Scotts Valley, C, ine, Santa Cruz, CA; n, Santa Cruz, CA; , Soquel, CA;	A;Philip A. Troiani, Sa	inta Cruz, CA;				
** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
IF REQUIRED, FOREI ** 04/23/2001	GN FILING LICENSE G	GRANTED					
Foreign Priority claimed 35 USC 119 (a-d) conditions met	yes no Met after	STATE OR	SHEETS	TOTAL	INDEPENDENT		
Verified and Acknowledged Exa	Allowance  Allowance	COUNTRY CA	DRAWING 16	CLAIMS 6	CLAIMS 2		
ADDRESS Maria S. Swiatek FLEHR HOHBACH TE Four Embarcadero Cer San Francisco , CA 94111-4187	ST ALBRITTON & HER nter, Suite 3400	BERT LLP					
NTLE Semiconductor wafer p ransfer system	rocessing system with v	vertically-stacked proc	ess chambers	and single-ax	ris dual-wafer		
FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:  RECEIVED  All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)							



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Bib Data Sheet				CONFIR	MATION NO. 289
SERIAL NUMBER 09/767,659	FILING DATE 01/22/2001 RULE	CLASS 438 414	GROUP ART UNIT		ATTORNEY DOCKET NO. A-67736- 1/AJT/MSS
APPLICANTS				<u></u>	
Frank S. Mena Helder R. Can Philip A. Troia Dan L. Cosser	vage, Scotts Valley, CA agh, Santa Cruz, CA; valheria, Scotts Valley, ni, Santa Cruz, CA; atine, Santa Cruz, CA; an, Santa Cruz, CA; er, Soquel, CA;			-	
AND CLAIMS	ATION IS A DIV OF 09/ BENEFIT OF 60/127,53 BENEFIT OF 60/127,65	32 04/02/1999	·		
GRANTED ** 04/23/2	EIGN FILING LICENSE	· •	-		
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged Exa	yes no Met after  Allowance  Miner's Signature  Month	2 CA	SHEETS DRAWING 16	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 2
ADDRESS	Trial Control of the			l	
Maria S. Swiatek FLEHR HOHBACH TI Four Embarcadero Ce San Francisco ,CA 94		RBERT LLP		•	
TITLE Semiconductor wafer ransfer system	processing system with	vertically-stacked pr	ocess chamb	ers and singl	e-axis dual-wafer
FILING FEE FEES RECEIVED No 710 No	: Authority has been giv to charge/cred for following:	ven in Paper dit DEPOSIT ACCO	JNT time)	6 Fees ( Filli 7 Fees ( Pro 8 Fees ( Issu	cessing Ext. of